APPLICATION DATA SHEET

Application Information

Application Number:: Not yet assigned

Filing Date:: Herewith

Application Type:: Regular

Subject Matter:: Utility

CD-ROM or CD-R?::

Number of CD Disks::

Number of Copies of CDs::

Sequence Submission?::

Computer Readable Form (CRF)?::

Number of Copies of CRF::

Title:: CONTROL OF PLASMA TRANSITIONS IN

SPUTTER PROCESSING SYSTEMS

Attorney Docket Number:: ASX-064

Request for Early Publication?::

Request for Non-Publication?::

Suggested Drawing Figure::

Total Drawing Sheets:: 10

Small Entity?:: No

Licensed US Govt. Agency::

Contract or Grant Numbers::

Secrecy Order in Parent Appl.?::

Applicant Information

Applicant Authority Type:: Inventor

Primary Citizenship Country:: US

Status:: Full Capacity

Given Name:: Jeff

Middle Name:: C.

Family Name:: Sellers

Name Suffix::

City of Residence::

Manchaca

ΤX

State or Province of Residence::

Country of Residence::

US

Street of Mailing Address:: 2802 Chaparral Road

City of Mailing Address::

Manchaca

State or Province of Mailing Address:: TX

Country of Mailing Address::

Postal or Zip Code of Mailing Address:: 78652

Correspondence Information

Correspondence Customer Number:: 021323

Representative Information

Representative Customer Number::

021323

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This application		0#/###,###	MM/DD/YY

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
		MM/DD/YY	
		1	

Assignee Information

Assignee Name::

ENI Technology, Inc.

City of Mailing Address::

Rochester

State or Province of Mailing Address:: NY

Country of Mailing Address:: US